<u>\$</u>		Appro U.S. Patent and Tradem	oved for use through 07/31/2006. OMB nark Office; U.S. DEPARTMENT OF C	0651-0031 0651-0031 OMMERCE
Inder the Paperwork Reduction Act of 1995, no pers	ons are required to res	pond to a collection of inform Application Number	nation unless it displays a valid OMB con	rol number. 744
TRANSMITTAL FORM  (to be used for all correspondence after initial filling)		Filing Date	March 25, 2004	
		First Named Inventor	Yoshitaka HAMADA	
		Art Unit	2891	
		Examiner Name	D. M. Menz	
Total Number of Pages in This Submission 4		Attorney Docket Numb	0171-1076PUS1	
ENCLOSURES (Check all that apply)				
Fee Transmittal Form  Fee Attached  X Reply to Restriction Requirement  After Final  Affidavits/declaration(s)  Extension of Time Request  Express Abandonment Request  Information Disclosure Statement  Certified Copy of Priority	Drawing(s)  Licensing-rel Petition  Petition to Co Provisional A Power of Attor Change of Co Terminal Disc Request for  CD, Number	ated Papers  onvert to a application mey, Revocation arrespondence Address claimer  Refund	After Allowance Communic to TC  Appeal Communication to E Appeals and Interferences  Appeal Communication to I (Appeal Notice, Brief, Reply E Proprietary Information  Status Letter  X Other Enclosure(s) (please Identify below):	Board of
Reply to Missing Parts/ Incomplete Application  Reply to Missing Parts under 37 CFR 1.52 or 1.53	Remarks		· · · · · · · · · · · · · · · · · · ·	
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT				
Firm Name BIRCH, STEWART, KOLASCH & BIRCH, LLP				
Signature	n &	#3Zyy	1	

Gerald M. Murphy, Jr. Printed name Date Reg. No. 28,977 DEC 3.0 2005



Docket No.: 0171-1076PUS1

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Yoshitaka HAMADA et al.

Application No.: 10/808,361

Confirmation No.: 004744

Filed: March 25, 2004

Art Unit: 2891

For: POROUS FILM, COMPOSITION AND

MANUFACTURING METHOD,

INTERLAYER DIELECTRIC FILM, AND

SEMICONDUCTOR DEVICE

Examiner: D. M. Menz

## REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the Restriction Requirement dated December 15, 2005, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: remarks.